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PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Tongbi Jiang Attorney Docket No. : 500182.01 (660073.774)
Serial No. : 09/365,356 Group Art Unit : 2813
Filed : July 30, 1999 Examiner : Nema O. Berezny
Title : METHOD AND STRUCTURE FOR MANUFACTURING IMPROVED YIELD
SEMICONDUCTOR PACKAGED DEVICES

REQUEST FOR CONTINUED EXAMINATION (RCE)
UNDER 37 C.F.R. § 1.114

RECEIVED

SEP 30 2003

OFFICE OF PETITIONS

Mail Stop Office of Petitions
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant requests continued examination, under 37 C.F.R. § 1.114, of the above-identified application.

1. Submission Required Under 37 C.F.R. § 1.114

- a. ☐ Submission previously submitted
- i. ☐ Consider the amendment/reply under 37 C.F.R. § 1.116 previously filed on _____.
 - ii. ☐ Consider the arguments in the Appeal Brief or Reply Brief previously filed on _____.
 - iii. ☐ Consider the Information Disclosure Statement (IDS) previously filed on _____.
- b. ☒ Submission enclosed
- i. ☐ Amendment/Reply
 - ii. ☐ Affidavit(s)/Declaration(s)
 - iii. ☒ Information Disclosure Statement (IDS)

2. Suspension of Action (Period of suspension shall not exceed 3 months; fee under 37 C.F.R. § 1.17(i) required)

☐ Suspension of action on the above-identified application is requested under 37 C.F.R. § 1.103(c) for a period of ____ months.

3. Accompanying Papers

☒ Postcard
☒ Check
☒ Fee Transmittal Sheet
☒ Petition


4. Deposit Account

☒ The Commissioner is authorized to charge any additional fees required in the above-identified patent application to Deposit Account No. 50-1266.

Respectfully submitted,

Tongbi Jiang

Date: 9/29/03

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